



PATENT  
Docket No.: ACT-311

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815

Examiner: Jose R. Diaz

Serial No.: 09/737,642

Filed: December 14, 2000

In re Application of: Daniel C. Wang

For: METAL-TO-METAL ANTIFUSE STRUCTURE AND FABRICATION  
METHOD

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 6/24/03.

Signed Stephanie Davis  
Stephanie Davis

# 11/C  
7/11/03  
Jun.

**RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The following is being submitted in response to the Office Action dated March 14, 2003. Please amend the application as follows:

RECEIVED  
JUN - 1 2003  
TECHNOLOGY CENTER 2800